

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Zheng et al.
Serial No. : To be assigned
Filed: : Herewith
Title : ATOMIC LAYER DEPOSITION OF CAPACITOR DIELECTRIC
Docket No. : MIO 0082 N2

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

OFFICIAL COMMUNICATION


This Official Communication is in regard to a continuation patent application filed herewith, which claims priority to currently pending patent application Serial No. 10/228,911 filed August 27, 2002.

This continuation application is being filed in the present case by filing a new specification with new claims, along with the oath or declaration from the prior (parent) application pursuant to 37 CFR 1.53(b). The text of the newly filed specification includes an amended "Cross Reference to Related Applications" and any/all changes to the specification made during prosecution of the parent application from which this continuation claims priority.

Applicant respectfully submits that the claims of the present continuation application represent allowable subject matter. The Examiner is encouraged to contact the undersigned to resolve efficiently any formal matters or to discuss any aspects of the application or of this Official Communication. Otherwise, early allowance is respectfully solicited.

Respectfully submitted,
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By


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